GAU2815 #6

PATENT 3430-0131P

IN THE U.S. PATENT AND TRADEMARK OFFICE

policant:

HWANG, Kwang-Jo

Conf.:

Appl. No.:

09/648,111

Group:

2815

Filed:

August 25, 2000

Examiner: Brock II,

For:

METHOD OF PATTERNING A METAL LAYER IN A

SEMICONDUCTOR DEVICE

LARGE ENTITY TRANSMITTAL FORM

Assistant Commissioner for Patents Washington, DC 20231

August 23, 2001

Sir:

Transmitted herewith is an amendment in the above-identified application.

The enclose	ed document	is	being	transmi	tted	via	the	Certificate
of Mailing	provisions	of	37 C.	F.R. §	1.8.			

The enclosed document is being transmitted via facsimile.

The fee has been calculated as shown below:

	CLAIMS REMAINING AFTER AMENDMENT		HIGHEST NUMBER PREVIOUSLY PAID FOR		PRESENT EXTRA	RATE	ADDITIONAL FEE
TOTAL	29	_	29	=	0	\$18	\$0.00
INDEPENDENT	3	-	3	=	0	\$80	\$0.00
FIRST PRESENTATION OF A MULTIPLE DEPENDENT CLAIM							\$0.00
						TOTAL	\$0.00

Appl. No. 09/648,111

\boxtimes	Petition for one (1) month(s) extension of time pursuant to 37 C.F.R. §§ 1.17 and 1.136(a). $$110.00$ for the extension of time.
	No fee is required.
\boxtimes	A check in the amount of \$110.00 is enclosed.
	Please charge Deposit Account No. 02-2448 in the amount of \$0.00. This form is submitted in triplicate.

If necessary, the Commissioner is hereby authorized in this, concurrent, and future replies, to charge payment or credit any overpayment to Deposit Account No. 02-2448 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

Ву

/-//

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Falls Church, VA 22040-0747

(703) 205-8000

ATTACHMENT

GDY/PLS:sld

3430-0131P

(Rev. 01/22/01)



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S):

HWANG, Kwang-Jo

SERIAL NO.:

09/648,111

GROUP:

2815

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August 25, 2000

EXAMINER: Brock II, P.

FOR:

METHOD OF PATTERNING A METAL LAYER IN A

SEMICONDUCTOR DEVICE

RULE 111 AMENDMENT

Assistant Commissioner for Patents Washington, D.C. 20231

August 23, 2001

Dear Sir:

In response to the Office Action dated April 24, 2001, the following amendments and remarks are respectfully submitted under 37 C.F.R. §1.111 in connection with the above-identified application.

IN THE CLAIMS:

Please amend claims 1, 12 and 22 as follows:

1. A method of manufacturing a liquid crystal display device, comprising:

forming a switching element on a substrate;

forming a passivation layer over the substrate;

depositing a metal layer on the passivation layer;

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